

Notice of References Cited	Application/Control No. 10/809,929	Applicant(s)/Patent Under Reexamination NAKAMURA ET AL.	
	Examiner David S. Kim	Art Unit 2613	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0013615 A1	01-2005	Matsuda, Osamu	398/083
*	C	US-2005/0041975 A1	02-2005	Nakamura et al.	398/085
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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